



THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Katsuto TANAHASHI et al.**

Art Unit: **2815**

Application Number: **10/743,793**

Examiner: **Jay C. Kim**

Filed: **December 24, 2003**

Confirmation Number: **9788**

For: **SEMICONDUCTOR SUBSTRATE AND MANUFACTURING METHOD
THEREOF**

Attorney Docket Number: **032206**

Customer Number: **38834**

AMENDMENT UNDER 37 C.F.R. §1.114
EXPEDITED PROCESSING REQUESTED

MAIL STOP: RCE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

December 30, 2008

Sir:

In response to the Office Action dated September 2, 2008, this Submission is being filed concurrently with a Request for Continued Examination pursuant to 37 C.F.R. §1.114, the response date of which having been extended by one month to January 2, 2009, Applicants amend the claims as follows and submit the following remarks.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.